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thin solid films

Contents

Letter

Atomistic simulation of $SrTiO_3$ and $BaTiO_3$ (110) surface relaxations
E. Heifets, E.A. Kotomin 1

Synthesis and Characterization

Low resistance Au contacts to epitaxial n-CdTe formed by excimer laser induced diffusion of In
F.X. Wagner, D. Sands 6

Structural transition from CdTe to $CdIn_2Te_4$ in films grown by close paced vapor transport combined with free evaporation
M. Zapata-Torres, R. Castro-Rodríguez, M. Melendez-Lira, S. Jimenez-Sandoval, A. Zapata-Navarro, J.L. Peña 12

Optical and microstructural properties of sol–gel derived titania/organically modified silane thin films
W. Que, Y. Zhou, Y.L. Lam, Y.C. Chan, C.H. Kam 16

Morphological and compositional study of CBD-ZnSe thin films by microscopy techniques and angle resolved XPS
A.M. Chaparro, C. Maffiotte, M.T. Gutiérrez, J. Herrero 22

Internal r.f. plasma parameters correlated with structure and properties of deposited hydrocarbon films
A. Hallil, B. Despax 30

Preparation and characterization of pyrolytic spray deposited electrochromic tungsten trioxide films
M. Regragui, M. Addou, A. Outzourhit, J.C. Bernéde, E. El Idrissi, E. Benseddik, A. Kachouane 40

Unidirectional multiple cracking of coatings described through random sequential placement of rods on a line
A. Mézin, B. Sajid 46

Raman spectroscopy study of amorphous SiGe films deposited by low pressure chemical vapor deposition and polycrystalline SiGe films obtained by solid-phase crystallization
J. Olivares, P. Martín, A. Rodríguez, J. Sangrador, J. Jiménez, T. Rodríguez 56

AFM study of templated growth of cadmium sulfide nanoparticles using pure and mixed arachidate films
H. Li, G. Mao, K.Y. Simon Ng 62

Deriving the kinetic parameters for Pt-silicide formation from temperature ramped in situ ellipsometric measurements
T. Stark, H. Grünleitner, M. Hundhausen, L. Ley 73

Structural properties of thin $Zn_{0.62}Cu_{0.19}In_{0.19}S$ alloy films grown on Si(111) substrates by pulsed laser deposition
G. Wagner, U. Lange, K. Bente, J. Lenzner, M. Lorenz 80

Effect of lead acetate concentration on the droplet size in liquid source misted chemical deposition
W.S. Moon, H.J. Chung, S.B. Park, S.I. Woo 86

Metal oxide/silicon oxide multilayer with smooth interfaces produced by in situ controlled plasma-enhanced MOCVD
F. Hamelmann, G. Haindl, J. Schmalhorst, A. Aschentrup, E. Majkova, U. Kleineberg, U. Heinzmann, A. Klipp, P. Jutzi, A. Anopchenko, M. Jergel, S. Luby 90

Misfit dislocations of epitaxial (110) niobium‖ $(11\bar{2}0)$ sapphire interfaces grown by molecular beam epitaxy
E.J. Grier, M.L. Jenkins, A.K. Petford-Long, R.C.C. Ward, M.R. Wells 94

Preparation of ZnF_2 and ZnF_2–BaF_2 thin films by electron cyclotron resonance plasma-enhanced chemical vapor deposition
M. Shojiya, Y. Kawamoto, A. Konishi, H. Wakabayashi 99

Synthesis of tantalum pentoxide films by pulsed laser deposition: material characterization and scale-up
S. Boughaba, G.I. Sproule, J.P. McCaffrey, M. Islam, M.J. Graham 104

Surfaces, Interfaces and Colloidal Behaviour

Photoinduced effects in silicon glass coated by In_2O_3–Sn thin layer
Z. Olesik, I.V. Kityk, J. Kasperczyk, J. Olesik, A. Mefleh 114

Nanocrystalline TiO_2 studied by optical, FTIR and X-ray photoelectron spectroscopy: correlation to presence of surface states
P.M. Kumar, S. Badrinarayanan, M. Sastry 122

Metallurgical, Protective and Hard Layers

Low temperature pulsed laser deposition of titanium carbide on bearing steels
G. Radhakrishnan, P.M. Adams, D.M. Speckman 131

Dynamic mechanical properties of ZrO_2/NiCoCrAlY composite coatings
C.T. Chia, K.A. Khor, Y.W. Gu. 139

Mechanics and Nanomechanics of Thin Layers

FIB micromachined submicron thickness cantilevers for the study of thin film properties
J. McCarthy, Z. Pei, M. Becker, D. Atteridge 146

Structural characterization and frictional properties of C_{60}-terminated self-assembled monolayers on Au(111)
S. Lee, Y.-S. Shon, T. Randall Lee, S.S. Perry 152

Interfacial mechanical properties and fracture morphology of a TiN-coated steel wire upon tensile loading
M.H. Shiao, F.S. Shieu 159

Electronics, Optics and Opto-electronics

Simple method for determining the optical constants of thin metallic films from transmittance measurements
E.E. Khawaja, S.M.A. Durrani, A.M. Al-Shukri 166

Preparation and photoelectrochemical properties of porous thin films composed of submicron TiO_2 particles
H. Kozuka, Y. Takahashi, G. Zhao, T. Yoko 172

Passivation of copper films with magnesium doping using recoil ion implantation
Z.-C. Wu, Y.-L. Liu, M.-C. Chen. 180

Pulsed laser deposition of aluminum tris-8-hydroxyquinline thin films
X. Yang, Y. Tang, M. Yu, Q. Qin 187

Realisation and characterisation of LiF/NaF thin film planar waveguides
L. Fornarini, S. Martelli, R.M. Montereali, G.C. Righini, S. Pelli, M. Cremona 191

Analysis of the broadening of photoluminescence spectra in porous silicon as a function of growth parameters
V. Agarwal, R.M. Mehra, P.C. Mathur 196

Influence of film density on residual stress and resistivity for Cu thin films deposited by bias sputtering
H.M. Choi, S.K. Choi, O. Anderson, K. Bange. 202

Magnetics and Magneto-optics

Structural, magnetic and magneto-optical properties of $SrFe_{12-x}Al_xO_{19}$ hexaferrite thin films prepared by laser ablation deposition
O. Heczko, R. Gerber, Z. Šimša. 206

Development of SiN_x and AlN_x passivation layers
J.-W. Lee, S.C.N. Cheng 215

Superconductivity

Effects of target microstructure on pulsed laser deposited $YBa_2Cu_3O_{7-\delta}$ thin films
C.-H. Kim, I.-T. Kim, K.-S. Hong, T.-S. Hahn, S.-S. Choi. 223

Langmuir–Blodgett, Biological and Related Films

Langmuir and Langmuir–Blodgett films of octadecylaminodihydroxysalicylaldehyde
S.J. Collins, A. Dhathathreyan, T. Ramasami, H. Möhwald 229

Thin block copolymers films: film formation and corrugation under an AFM tip
J.H. Maas, M.A. Cohen Stuart, G.J. Fleer 234

Scanning tunneling microscopy investigation of tricycloquinazoline liquid crystals on gold
R. Hiesgen, H. Schönherr, S. Kumar, H. Ringsdorf, D. Meissner 241

Thin Film Devices, Sensors and Actuators

HfO_2 films with high laser damage threshold
M. Alvisi, M. Di Giulio, S.G. Marrone, M.R. Perrone, M.L. Protopapa, A. Valentini, L. Vasanelli 250

Condensed Matter Film Behaviour

Structural change and photo-response in porous poly-Si/Si
J. Lyou, K.-S. Yoon, E.K. Kim, S.-K. Min 259

Texture development in silver films deposited by ionised magnetron sputter deposition
K.-F. Chiu, Z.H. Barber 264

Study of Pt/Ge interaction in a lateral diffusion couple by microbeam Rutherford backscattering spectrometry
R.S. Nemutudi, C.M. Comrie, C.L. Churms 270

Growth of (111)-oriented PbTe films on Si(001) using a BaF_2 buffer
A. Belenchuk, A. Fedorov, H. Huhtinen, V. Kantser, R. Laiho, O. Shapoval, V. Zakhvalinskii 277

A new method for analysis of isothermal discharging current
E.R. Neagu, R.M. Neagu 283

Oriented wedge-like hillocks on Al-0.5 wt.%Cu/TiN/SiO_2/Si multilayer structure
P. Wang, J. Hwang, A. Chuang, F.-S. Huang 292

Author Index of Volume 358 303

Subject Index of Volume 358 305

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